



Docket No. 7407562435

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Hirokazu YAMAGATA et al.) Group Art Unit: 2823
Serial No. 10/073,284) Examiner: S. Foong
Filed: February 13, 2002)
For: **LIGHT EMITTING DEVICE AND**) Date: November 21, 2002
METHOD OF MANUFACTURING THE)
SAME)

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on November 21, 2002.

Adele Stamper
Adele Stamper

**RESPONSE TO RESTRICTION REQUIREMENT
AND AMENDMENT**

Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action mailed October 21, 2002, please amend the application as follows:

IN THE CLAIMS:

Please amend the claims as follows:

50. (Amended) A method of manufacturing a device comprising the steps of:
forming a thin film transistor formed over a substrate having an insulating surface;
forming an interlayer insulating film over the thin film transistor;
forming an electrode over the interlayer insulating film;

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